



THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Yamazaki, et al.

Art Unit : 2871

Serial No. : 09/517,354

Examiner : Kenneth Parker

Filed : March 2, 2000

Title : METHOD OF MANUFACTURING A DISPLAY DEVICE HAVING A DRIVER
CIRCUIT ATTACHED TO A DISPLAY SUBSTRATE

Commissioner for Patents

P.O. Box 1450

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INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

Submitted herewith is an English translation of the following foreign language
references, or portions thereof:

| Desig. ID | Source |
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| AO | Japan 06-310570 A - English Abstract: DERWENT-ACC-NO: 1995-026177; DERWENT-WEEK: 199504; Copyright 1999 DERWENT INFORMATION LTD |
| AP | Japan 06-295940 A - English Abstract: DERWENT-ACC-NO: 1995-010440; DERWENT-WEEK: 199502; Copyright 1999 DERWENT INFORMATION LTD |
| AQ | Japan 04-275444 A - No Abstract: DERWENT-ACC-NO: 1992-376410; DERWENT-WEEK: 199246; Copyright 1999 DERWENT INFORMATION LTD. |
| AR | Japan 06-268022 A - No Abstract: DERWENT-ACC-NO: 1994-345113; DERWENT-WEEK: 200121; Copyright 1999 DERWENT INFORMATION LTD. and family to JP 3151995 B2 |
| AS | Japan 47-18298 - Full English Translation; Japan Patent Office |
| AT | Japan 49-126350 - Full English Translation; Japan Patent Office |
| AU | Japan 51-065656 - Full English Translation; Japan Patent Office |
| AV | Japan 53-091763 - Full English Translation; Japan Patent Office |
| AW | Japan 59-057221 - Full English Translation; Japan Patent Office |
| AX | Japan 59-171925 - Full English Translation; Japan Patent Office |
| AY | Japan 59-195222 - Full English Translation; Japan Patent Office |
| AZ | Japan 60-021028 - Full English Translation; Japan Patent Office |
| AAA | Japan 60-075817 - Full English Translation; Japan Patent Office |
| ABB | Japan 60-111221 - Full English Translation; Japan Patent Office |
| ACC | Japan 60-126624 - Full English Translation; Japan Patent Office |
| ADD | Japan 61-190313 - Full English Translation; Japan Patent Office |
| AEE | Japan UM-B-50-15495 - Full English Translation; Japan Patent Office |
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Serial No. : 09/517,354
Filed : March 2, 2000
Page : 2 of 2

Attorney's Docket No.: 07977-
015003 / US2954/2957D1D1

This filing is being made with the filing of a Request for Continued Examination. No fees are believed to be due. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: 6/2/04



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| Substituted Form (Revised) JUN. 0 2 2000 (37-CFR 51.201-2) | PTO-1449 | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-015003 | Application No. 09/517,354 |
| | Information Disclosure Statement by Applicant (Use several sheets if necessary) | | | |
| | Applicant Yamazaki, et al. | | Filing Date March 2, 2000 | Group Art Unit 2871 |

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Examiner Signature

Date Considered

EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Substitute Disclosure Form (PTO-1449)

| | | | |
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| Patent Form PTO-1449 (Modified) JUN. 0 2 2000 INFORMATION DISCLOSURE STATEMENT by Applicant (Use several sheets if necessary) (37 CFR 1.212(b)) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 07977-015003 | Application No. 09/517,354 |
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| Other Documents (include Author, Title, Date, and Place of Publication) | | |
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| | AII | |
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|--|-----------------|
| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |